



Docket No.: 204552030700  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yoshiaki UEDA et al.

Application No.: 10/715,025

Confirmation No.: 3319

Filed: November 18, 2003

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE AND  
MANUFACTURING METHOD THEREFOR

Examiner: T. T. Van Roy

**AMENDMENT UNDER 37 CFR 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 7, 2006, please amend this application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.